

**WORK IN PROGRESS**

## **Applying Overt Systems Thinking to the Design of the Femtosource**

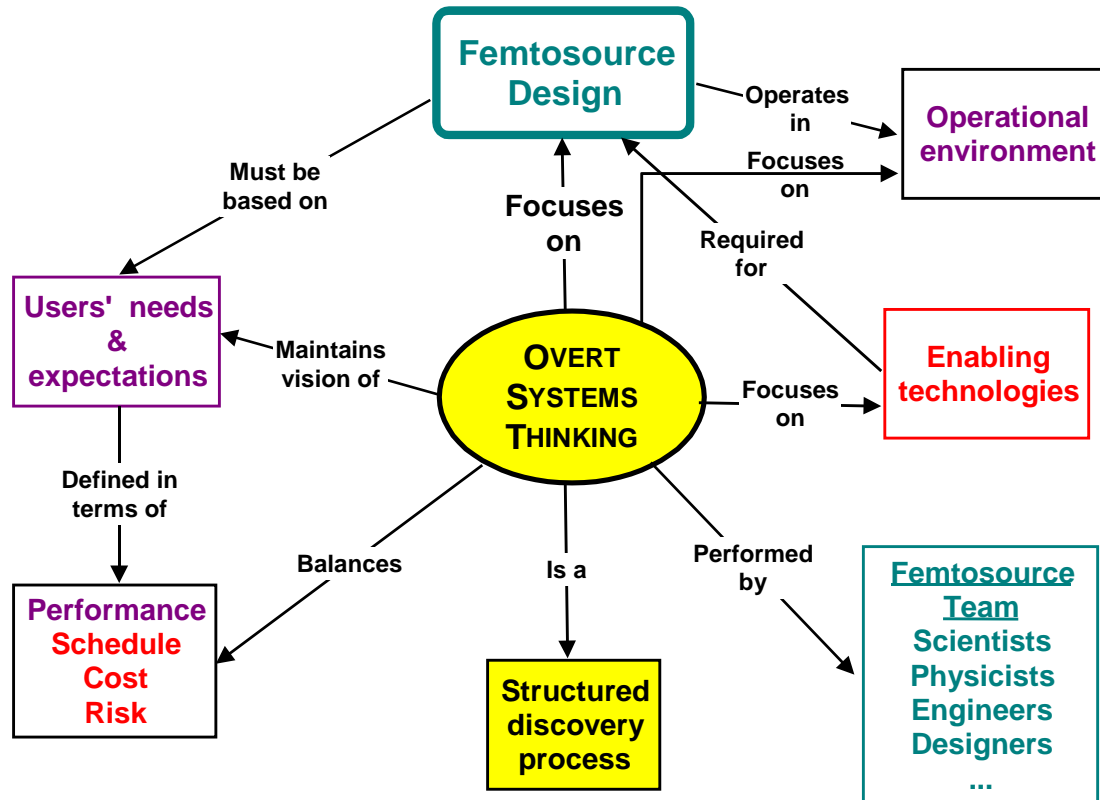
**Ed Kujawski  
Systems Engineering  
x6932**

### **Topics**

- Key principles of "systems thinking" for designing the femtosource
- Defining the femtosource trade space
- Mathematical formulation of the design problem
  - ☞ Limitations and complications
- Some simplified equations for insight into the femtosource trade space
- Identifying injector-gun alternatives
- Preliminary evaluation of Risk Vs. Performance for the Cs<sub>2</sub>Te cathode
- The DoE model of a project life-cycle
- The next step?

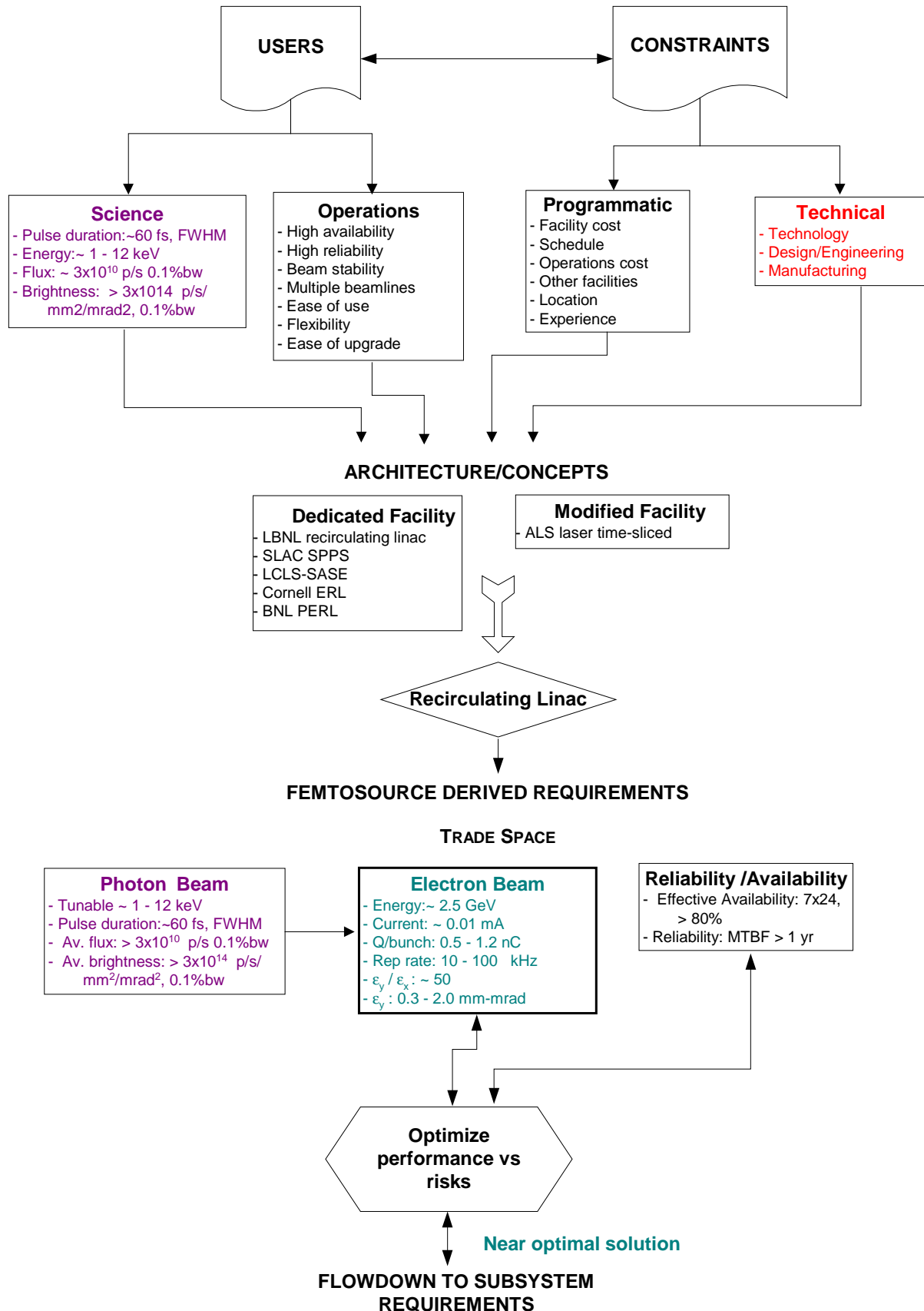
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### Key Principles of Systems Thinking for the Femtosource



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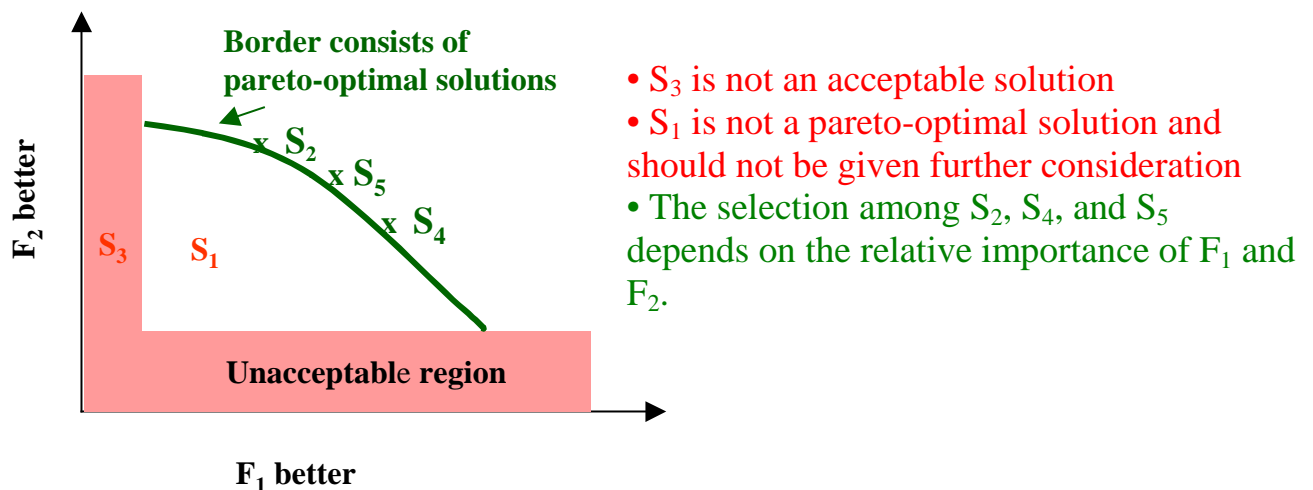
### Defining the Femtosource Trade Space



## Mathematical Formulation of the Design Problem

✓ Simultaneously optimize several possibly conflicting criteria given by functions  $\{F_1, F_2, \dots, F_n\}$  that depend on the design variables  $\{x_1, \dots, x_k\}$  and are subject to the constraints,  $\{C_1, \dots, C_m\}$ .

☞ **This is formally nice, but there may not be a dominant solution!**  
**Also system design is an NP-complete problem!**



**It is important and simple (but not easy) to achieve a "near optimal" design given a feasible design!**

## Some Simplified Models for Insight into the Design Trade Space

### Notes:

#### - Color code

**XXX: Technology constraint**

**YYY: Science driver**

**ZZZ: Design trade**

#### - Use of natural units.

### 1. Cathode Emittance (C. Sinclair)

$Q_b \leq Q_{\text{stored}} / 10$  : To avoid space charge problems

$$\epsilon_n [\text{mm-mrad}] \geq \{(Q_b [\text{pC}] / 111 * EF_{\text{cath}} [\text{MV/m}] * E_{\text{thermal}} [51 \text{ meV}])\}^{1/2}$$

To achieve lower emittance:

- ✓ Design photocathode and gun cavity with
  - Lower characteristic energy of emitted  $e^-$ s,  $E_{\text{thermal}}$
  - Higher E-field at cathode,  $EF_{\text{cath}}$
- ✓ Reduce charge per bunch,  $Q_b$

### 2. Photoinjector Laser Power, $P_{\text{laser}}$ (C. Sinclair)

$$P_{\text{laser}} [\text{W}] \geq (Q_b [\text{mC}] * R_r [\text{/sec}]) * (124 / \lambda_{\text{laser}} [\text{nm}]) / QE [\%]$$

To require lower laser power:

- ✓ Use cathode with higher quantum efficiency, QE
- ✓ Use cathode with lower operating wavelength,  $\lambda_{\text{laser}}$
- ✓ Reduce  $Q_b$
- ✓ Reduce repetition rate,  $R_r$

### 3. Flux, $S_n$ (LBNL X-Ray Data Booklet)

$$\epsilon_n [\text{keV}] = 0.95 * n * E_b^2 [\text{GeV}] / (1 + K^2/2) * \lambda_u [\text{cm}]$$

$$S_n [\text{ph/s-0.1\% bw}] = (1.431 * 10^{14}) * N_u * Q_n(K) * Q_b [\text{C}] * R_r [\text{/sec}]$$

$$K = 0.934 * \lambda_u [\text{cm}] * B_0 [\text{T}]$$

To achieve higher flux:

- ✓ Design higher performance undulator ( $B_0$ ,  $\lambda_u$ ,  $N_u$ )
- ✓ Design machine with higher beam current ( $Q_b$ ,  $R_r$ )

To achieve different photon energies:

- ✓ Select beam energy,  $E_b$
- ✓ Select and tune undulator parameters
- ✓ Use higher-order harmonics,  $n$

**WORK IN PROGRESS****4. Peak Brightness** (LBNL X-Ray Data Booklet)

$$\begin{aligned} \text{➤ } B_n(0,0) [\text{ph/s/mm}^2/\text{mrad}^2 \text{ 0.1\% bw}] &= S_n / \{ (2\pi)^2 \sigma_{Tx} * \sigma_{Ty} * \sigma_{Tx'} * \sigma_{Ty'} \} \\ \sigma_{Tx} &= \{ \sigma_x^2 + \sigma_r^2 \}^{1/2} ; \sigma_{Tx'} = \{ \sigma_{x'}^2 + \sigma_{r'}^2 \}^{1/2} \\ \sigma_{r'} &= (\lambda_n * L_u)^{1/2} ; \sigma_r = (\lambda_n / L_u)^{1/2} \end{aligned}$$

To achieve higher brightness:

- ✓ Increase flux
- ✓ Reduce beam sizes,  $\sigma_{Tx}$  and  $\sigma_{Ty}$
- ✓ Reduce beam divergences,  $\sigma_{Tx'}$  and  $\sigma_{Ty'}$

**5. Pulse Length,  $\sigma_z$**  (A. Zholents et al.)

$$\begin{aligned} \sigma_z &\geq (E_b / eU * k_{rf}) * \sigma_{y'}^{rf} * \{1 + (\sigma_r / \sigma_y)^2\}^{1/2} \\ \sigma_z &\geq (E_b / eU * k_{rf}) * \sigma_{y'}^{rf} * \{1 + (\sigma_{r'} / \sigma_{y'})^2\}^{1/2} \end{aligned}$$

To achieve lower pulse duration:

- ✓ Reduce the vertical angular size of the e-beam in the deflecting cavity,  $\sigma_{y'}^{rf}$
- ✓ Increase the RF deflection voltage,  $eU$
- ✓ Increase the RF wave number (frequency),  $k_{rf}$
- ✓ Reduce the diffraction limited size of the radiation,  $\sigma_r$

**Notes:**

- Need to examine the importance of the corrections and/or use more accurate equations where necessary.

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**Trade Studies: Injector cathode & laser**  
**Leading Photocathode Alternatives**

Criteria	RF Guns		DC Guns	
	Metal	Cs <sub>2</sub> Te <sup>8+</sup>	GaAs	CsSb
Projected Q <sub>bunch</sub> , nC <sup>+</sup>	1.0	1.0	1.0	
I, mA <sup>+</sup>	0.01	0.01	0.01	
Normalized emittance, measured @1nC, mm-mr	?	2.8	?	
Projected normalized emittance, mm-mr@1nC <sup>+</sup>	1.0	1.0	1.0	
E <sub>thermal</sub> , β(51 meV = 300 <sup>0</sup> K)	?	6.0	1.2	
EF <sub>cath</sub> , measured, MV/m	?	35 - 40	10 - 20	
Projected EF <sub>cath</sub> , MV/m <sup>+</sup>	?	54.1	10.8	
P*Qe, W-%	0.0045	0.0045	0.0015	
Best Qe, measured, %		24 @ prep		14@ start
Projected life, years	years	years*	years^	Low <sup>@</sup>
Projected Qe, lifetime, %	0.01	1.0	10.0	
Lifetime limiting factors	Heat removal	Coating, Ion bombardment,...	Ion bombardment	
Needed improvements	Preparation technique	Preparation technique	- Field emission effects - DC power supply	
Probability of success / Confidence level	Medium	High/Medium	Medium	
Design complexity	- High vacuum	- High E <sub>cath</sub> - Low ε	- Very high vacuum	
Laser power, mW	450.0	4.5	0.15	
Laser sources	UV	UV below ~ 275nm	780nm	
Laser risk	Medium	Low	Low	
Comments	Not actively pursued by others because of low Q <sub>e</sub> .	1st choice: Tesla	- Jefferson Lab - PERL fallback	PERL studies
Conclusion ?	1st backup	Baseline	Open	Drop!

+ Femtosource Advisory Committee Meeting 12/7/01

& Use of A0 Photoinjector data

\* Based on QE of 2% for 200 mA after 1 year.

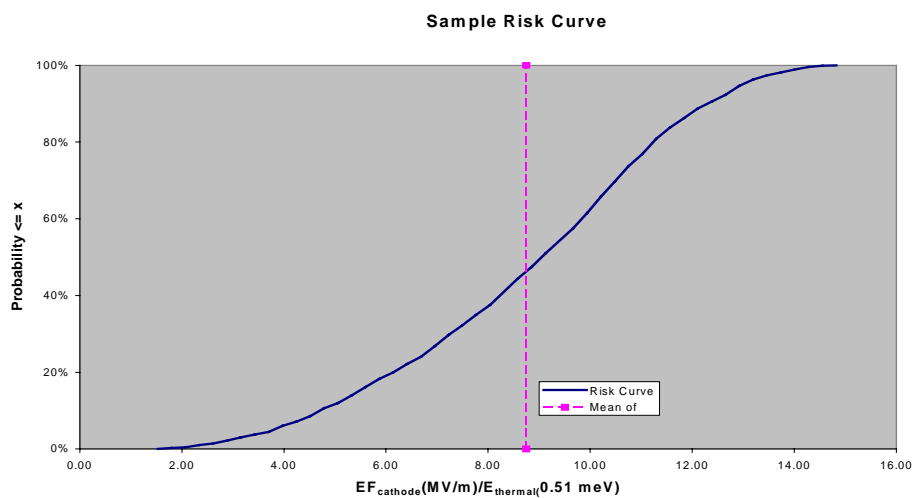
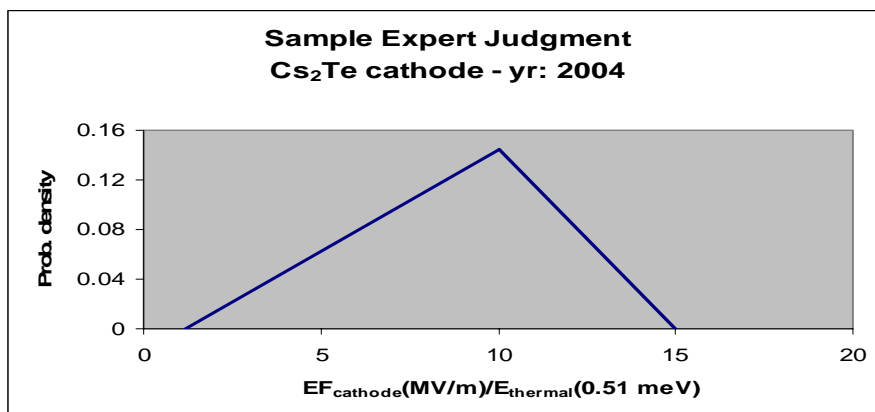
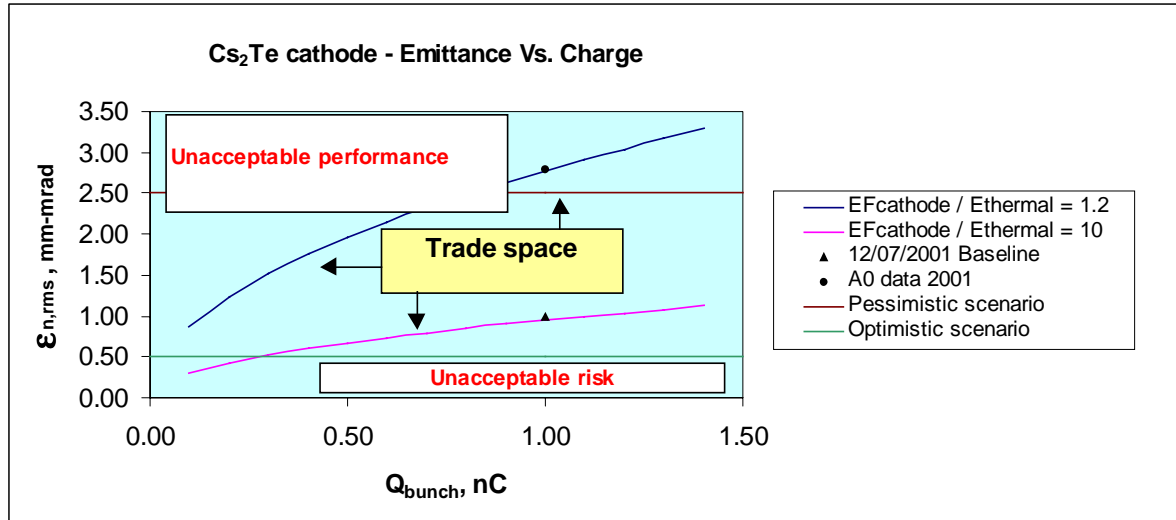
^Based on lifetime of 10<sup>5</sup> C/cm<sup>2</sup> for DC gun.

Scaled from 5 hours for a cathode spot size of 1 mm radius and 200 mA current.

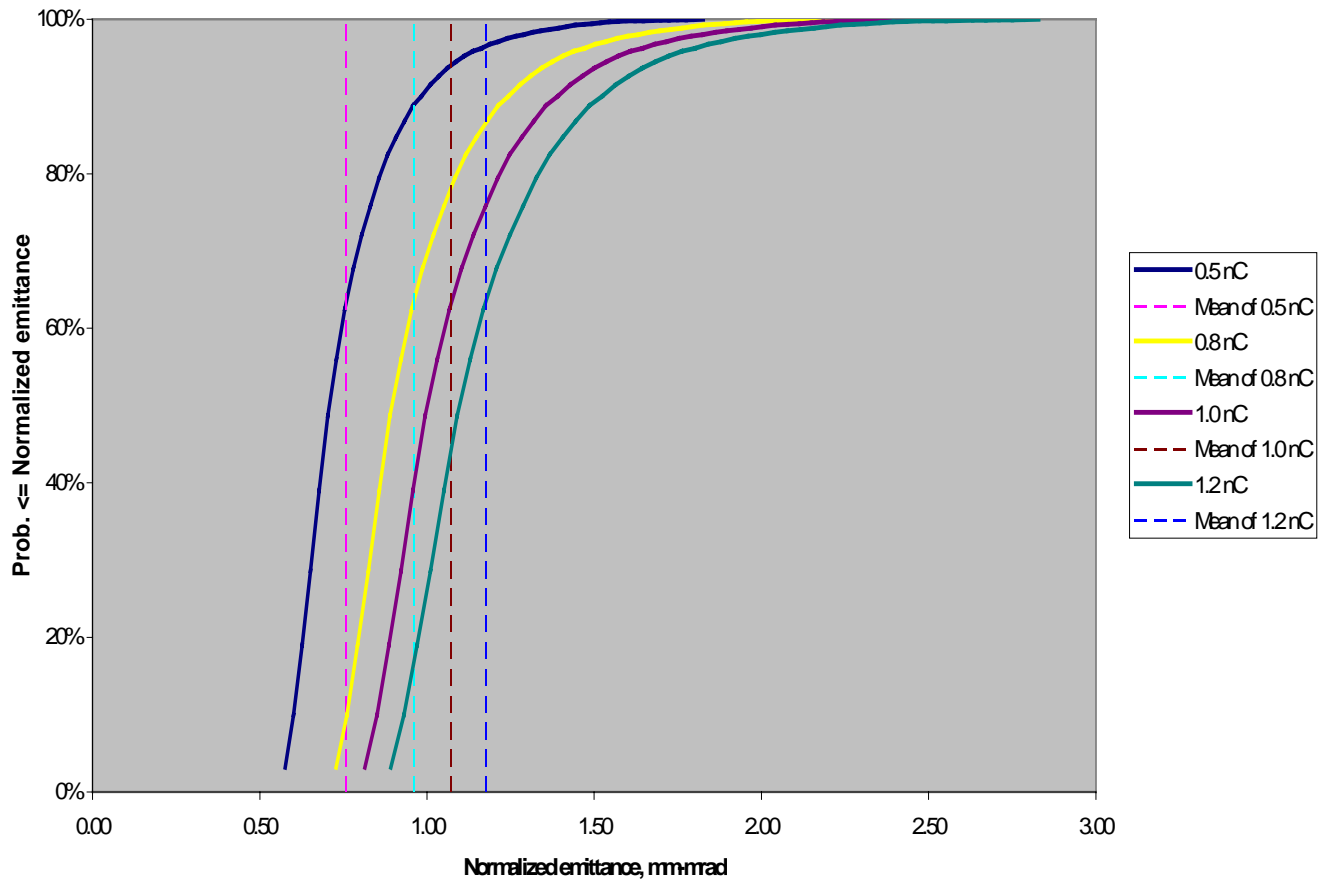
@ Lifetime decays exponentially. 2.3 hrs to Qe of 1% demonstrated in 1992.

**WORK IN PROGRESS****Cs<sub>2</sub>Te Cathode - Risk Vs. Performance**

$$\epsilon_n \text{ [mm-mrad]} \geq \{((Q_b[\text{pC}]/111 * EF_{\text{cath}}[\text{MV/m}]) * E_{\text{thermal}}[51 \text{ meV}])\}^{1/2}$$





**WORK IN PROGRESS****Emittance/ $Q_{\text{bunch}}$  Risk Profiles  
Cs<sub>2</sub>Te cathode - Yr 2004****Some Important Questions We Can Address**

- What is the impact on technical performance and risk of proceeding with a 1.2 nC / bunch Cs<sub>2</sub>Te design?
- What  $Q_{\text{bunch}}$  gives a  $\geq 80\%$  of probability of achieving an emittance  $\leq 1.0$  mm-mrad in the near future?
- Others?



